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[20103 00201]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Valerie S. SMIRNOV et al.  
International Appln. No. : PCT RU01 00261  
International Filing Date : July 2, 2001  
U.S. Appln. No. : 10.069,656  
Filing Date : February 25, 2002  
For : DEVICE FOR FORMING NANOSTRUCTURES  
ON THE SURFACE OF A SEMICONDUCTOR  
WAFER BY MEANS OF ION BEAMS

Commissioner for Patents  
P.O. Box 2327  
Arlington, VA 22202

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*Oleg F. Kaplun* 5/9/02

RESPONSE TO NOTICE OF MISSING REQUIREMENTS UNDER 35 U.S.C. 371

IN THE UNITED STATES DESIGNATED OFFICE (DO/EO/US)

S I R:

Transmitted herewith for filing in the above-identified application is a Response to the Notification of Missing Requirements mailed April 25, 2002. To complete the filing requirements for acceptance under 35 U.S.C. 371, herewith please find an executed Declaration.

No fees are believed to be required. However, if fees are required, please charge the deposit account of **Fay Kaplun & Marcin, LLP No. 50-1492**. A copy is enclosed for this purpose.

Respectfully submitted,

Dated: *May 9, 2002*

By: *Oleg F. Kaplun*  
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UNITED STATES PATENT AND TRADEMARK OFFICE

 OFFICE OF THE COMMISSIONER OF PATENTS AND TRADEMARKS  
 UNITED STATES PATENT AND TRADEMARK OFFICE  
 WASHINGTON, D.C. 20503-1418

U.S. APPLICATION NUMBER NO.	FIRST NAMED APPLICANT	ATTY. IN COUNTRY
10/069,656	Valerie S Smirnov	20103/00201

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INTERNATIONAL APPLICATION NO.	
PCT/RU01/00261	
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07/02/2001	07/04/2000

CONFIRMATION NO. 3563

371 FORMALITIES LETTER



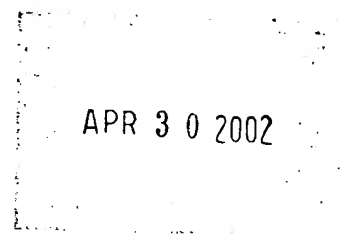
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Date Mailed: 04/25/2002

### NOTIFICATION OF MISSING REQUIREMENTS UNDER 35 U.S.C. 371 IN THE UNITED STATES DESIGNATED/ELECTED OFFICE (DO/EO/US)

The following items have been submitted by the applicant or the IB to the United States Patent and Trademark Office as a Designated Office (37 CFR 1.494):

- U.S. Basic National Fees
- Priority Document
- Copy of references cited in ISR
- Copy of the International Application
- Copy of the International Search Report
- Oath or Declaration
- Request for Immediate Examination



The following items **MUST** be furnished within the period set forth below in order to complete the requirements for acceptance under 35 U.S.C. 371:

- Oath or declaration of the inventors, in compliance with 37 CFR 1.497(a) and (b), identifying the application by the International application number and international filing date. The current oath or declaration does not comply with 37 CFR 1.497(a) and (b) in that it:
  - is not executed in accordance with either 37 CFR 1.66 or 37 CFR 1.68.

**ALL OF THE ITEMS SET FORTH ABOVE MUST BE SUBMITTED WITHIN TWO (2) MONTH FROM THE DATE OF THIS NOTICE OR BY 22 or 32 MONTHS (where 37 CFR 1.495 applies) FROM THE PRIORITY DATE FOR THE APPLICATION, WHICHEVER IS LATER. FAILURE TO PROPERLY RESPOND WILL RESULT IN ABANDONMENT.**

The time period set above may be extended by filing a petition and fee for extension of time under the provisions of 37 CFR 1.136(a).

Applicant is reminded that any communications to the United States Patent and Trademark Office must be mailed to the address given in the heading and include the U.S. application no. shown above (37 CFR 1.5)

A copy of this notice **MUST** be returned with the response.

DEBORAH D WILLIAMS

Telephone (703) 305-3744

PART 1 - ATTORNEY/APPLICANT COPY

U.S. APPLICATION NUMBER NO	INTERNATIONAL APPLICATION NO	ATTY DOCKET NO
10/069,656	PCT/RU01/00261	20103/00201

FORM PCT/DO/EO/905 (371 Formalities Notice)